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CONFIRMATION NO. 2213

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APPLICANTS Fumi Nabeshima, Hiratsuka-shi, JAPAN; Kazuya Togashi, Hiratsuka-shi, JAPAN; Hiroshi Jiken, Hiratsuka-shi, JAPAN; Yoshinori Suenaga, Hiratsuka-shi, JAPAN; ** CONTINUING DATA ***** This application is a CON of PCT/JP05/07120 04/13/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-117910 04/13/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/21/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged _____ Examiner's Signature	<input checked="" type="checkbox"/> Met after Allowance tc Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 6	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 2
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TITLE SEMICONDUCTOR WAFER INSPECTION DEVICE AND METHOD					
FILING FEE RECEIVED 1430	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		